

IN THE U.S. PATENT AND TRADEMARK OFFICE

I N F O R M A T I O N S H E E T

Applicant: Jeong-Jin KIM, Il-Ryong PARK, Hae-Joo CHOI
Appl. No.: NEW
Filed: December 4, 2000
For: APPARATUS FOR AND METHOD OF ETCHING AND
CLEANING OBJECTS

Priority Claimed:

Send Correspondence to:


BIRCH, STEWART, KOLASCH & BIRCH, LLP or CUSTOMER NO. 2292
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The above information is submitted to advise the U.S.P.T.O.
of all relevant facts in connection with the present application.

A timely executed Declaration in accordance with 37 C.F.R.
§ 1.64 will follow.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By  #37275
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TLC/TSA:sld
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